

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Yi-Hsun Wu, et al. Applicant:

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Examiner: Not Yet Assigned

2836

Serial No.: 10/687,314

Art Unit:

Filing Date: October 16, 2003

Conf. No.: 7810

Entitled:

Electrostatic Discharge

Protection Structure for

Deep Sub-Micron Gate Oxide§

## INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

The above-identified application was filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

Applicants believe no fee is due; However, the Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

David M. O'Dell

Registration No. 42,044

Date: 1-29-04

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450,

Bonnie Boyle

Printed Name

Signature

In place of PTO-1449 Form

U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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NFORMATION DISCLOSURE TATEMENT BY APPLICANT (use as many sheets as necessary)

	Complete if Known		
Application Number	10/687,314		
Filing Date	October 16, 2003		
Applicant(s)	Yi-Hsun Wu, et al.		
Art Unit 🐰 😹 🔭	Not Yet Assigned		
Examiner Name	Not Yet Assigned		
Attorney Docket Number	24061.27 (TSMC200		

01PE (6)

Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		A STORY OF THE PROPERTY OF THE

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent  Document  (Country Code - Number - Kind)	Publication Date	Patentee or Applicant of Cited Document	Translation YN
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		OTHER PRIOR ART
Examiner's	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher; city/country where published
	AA	URL: http://www.eedesign.com/article/showArticle.jhtml?articleId=16503875; VERHAEGE, KOEN G., ESD Process Shrinks I/Os Along Core Path, November 6, 2001, 4 pages, CMP Media LLC., 11/1/01, Issue #13149, page 22.

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

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